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## \*\* CONTINUING DATA \*\*\*\*\*

*none*  
*Loke*

## \*\* FOREIGN APPLICATIONS \*\*\*\*\*

JAPAN 2003-077648 03/20/2003

*Loke*

## IF REQUIRED, FOREIGN FILING LICENSE GRANTED

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Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no	STATE OR COUNTRY JAPAN	SHEETS DRAWING 5	TOTAL CLAIMS 22	INDEPENDENT CLAIMS 5
35 USC 119 (a-d) conditions met <input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> Met after Allowance				
Verified and Acknowledged <i>Loke</i> Examiner's Signature	<i>K.L.</i> Initials			

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## TITLE

Semiconductor device having metal silicide films formed on source and drain regions and method for manufacturing the same

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